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APPLICATION DATA SHEET

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*Applicant Information:*Inventor 1:

Applicant Authority Type: Inventor
Citizenship: JP
Given Name: Yasushi
Family Name: MURAKAMI
City of Residence: Nagano
Country of Residence: JP
Address-1 of Mailing Address: c/o Faculty of Textile Science and Technology,
Address-2 of Mailing Address: Organization of Shinshu University, 15-1, Tokida 3-
chome
City of Mailing Address: Ueda-shi, Nagano
State of Mailing Address:
Postal Code of Mailing Address: 386-8567
Address:
Country of Mailing Address: JP
Phone:
Fax:
E-mail:

Inventor 2:

Applicant Authority Type: Inventor
Citizenship: JP
Given Name: Masayuki
Family Name: HARANO
City of Residence: Nagano
Country of Residence: JP
Address-1 of Mailing Address: c/o HIOKI DENKI KABUSHIKI KAISYA
Address-2 of Mailing Address: 81, Aza Sakuramachi, O-Aza Koizumi
City of Mailing Address: Ueda-shi, Nagano
State of Mailing Address:

Postal Code of Mailing Address: 386-1192

Country of Mailing Address: JP

Phone:

Fax:

E-mail:

Inventor 3:

Applicant Authority Type: Inventor

Citizenship: JP

Given Name: Yoshio

Family Name: TAKASU

City of Residence: Nagano

Country of Residence: JP

Address-1 of Mailing Address: c/o Faculty of Textile Science and Technology,
Address-2 of Mailing Address: Organization of Shinshu University, 15-1, Tokida 3-
chome

City of Mailing Address: Ueda-shi, Nagano

State of Mailing Address:

Postal Code of Mailing
Address: 386-8567

Country of Mailing Address: JP

Phone:

Fax:

E-mail:

Inventor 4:

Applicant Authority Type: Inventor

Citizenship: JP

Given Name: Yoshio

Family Name: TANIGUCHI

City of Residence: Nagano

Country of Residence: JP

Address-1 of Mailing Address: c/o Faculty of Textile Science and Technology,
Address-2 of Mailing Address: Organization of Shinshu University, 15-1, Tokida 3-
chome

City of Mailing Address: Ueda-shi, Nagano

State of Mailing Address:

Postal Code of Mailing Address: 386-8567
Country of Mailing Address: JP
Phone:
Fax:
E-mail:

Correspondence Information:

Customer Number: 22204 *22204*

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practitioner(s) at Customer Number:

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as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

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Assignee Information:

Assignee 1:

Organization Name: Organization of Shinshu University

Address-1 of Mailing Address: 1-1, Asahi 3-chome

Address-2 of Mailing Address:

City of Mailing Address: Matsumoto-shi, Nagano

State of Mailing Address:

Postal Code of Mailing Address: 390-8621

Country of Mailing Address: JP

Phone:

Fax:

E-mail:

Assignee 2:

Organization Name: HIOKI DENKI KABUSHIKI KAISYA

Address-1 of Mailing Address: 81, Aza Sakuramachi, O-Aza Koizumi

Address-2 of Mailing Address:

City of Mailing Address: Ueda-shi, Nagano

State of Mailing Address:

Postal Code of Mailing Address: 386-1192

Country of Mailing Address: JP

Phone:

Fax:

E-mail: